# 1300M

Brown SE5/2A

CV 9 337



# DOUBLE GUN

#### **BRIEF DATA**

A high sensitivity double-gun oscilloscope tube with a 13 cm (5% inch) diameter faceplate and helical post deflection acceleration. The two identical electron guns have a common horizontal deflection system and independent vertical deflection systems.

HEATER									
Heater voltage					٠.			6.3	٧
Heater current (total)								0.6 or 1.2	Α

### **SCREEN**

Fluorescence .							-			Green	
Phosphorescend	e.						,			Green	
Persistence										1 – 5	ms
EIA phosphor c	ode									P31	
GEC phosphor	code									24	
Pro Electron ph	osph	or	СО	de						GH	

# EQUIPMENT DESIGN RANGE

Focus voltage . .

Control grid voltage			2.,0
for spot cut-off $-V_{01}$	60	30 -	$V/kV_{a1}$
Blanking voltage V <sub>o3</sub>	50	_	V/kV <sub>a1</sub>
Y deflection factor $D_{x}$ (at $V_{xx}/V_{xy} = 4$ )	6.6	5.4	V/cm/kV <sub>22</sub>

Max

400

Min

200

X deflection factor . . D<sub>x</sub> (at V<sub>a4</sub>/V<sub>a3</sub> = 4) 21 17 V/cm/kV<sub>a3</sub> p.d.a. spiral current . . . . . . . . . . . . . . . . 10  $-\mu$ A/kV<sub>a3e4</sub>

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# **RATINGS (Absolute)**

	Max	Min	
Fourth anode voltage V <sub>a4</sub>	8.0	3.0	kV
Third anode voltage	2.0	0.8	kV
Ratio $\cdot \cdot \cdot$	3 4,0	_	_
Focus voltage	1.5	0	kV
First anode voltage	2.0	0.8	kV
Control grid voltage	200	0	V
Y plate to third anode voltage	200	_	V
X plate to third anode voltage $V_{V=3}$	500	_	V
Heater - cathode voltage	180	-	V
Heater-cathode circuit resistance Rh.	1,5	_	МΩ
Y deflector plate circuit resistance R <sub>v-3</sub>	0.25	_	$\Omega$ M
X deflector plate circuit resistance Ryas	5.0	· <del>_</del>	МΩ
Grid to cathode circuit resistance R <sub>a1-k</sub>	1.5	_	$\Omega$ M
Geometry correction voltage	2.0	0.8	kV
Trace registration voltage	2.0	0.8	kV
Beam blanking voltage	2.0	0.8	kV

# CAPACITANCES (each gun)

Cathode to all other electrodes					5.5 8.5	pF pF
Blanking plate to all other electrodes (both guns)	,	•	•	•	12.0	<b>)</b> -
Deflector plates y1 to y2	•	•	٠	•	12,0	pF 
Deflector plates y1 to all electrodes except y2.	•	•	•	•		pF
Deflector plates y2 to all electrodes except y2.	•	•	•	•	4.0	. pF
Deflector plates v1 to v2	•	•	•	•	4.0	ρF
Deflector plates x1 to x2	٠	•	•	•	4.0	pΕ
Deflector plates x1 to all electrodes except x2.	•	•	٠	•	4.0	. p <u>F</u>
Deflector plates x2 to all electrodes except x1 .		•	•	٠	4.0	ρF

# TYPICAL OPERATION (All operating potentials are with respect to cathode)

·		
Fourth anode voltage V <sub>a4</sub>	4.0	kV
Third anode voltage	1.0	kV
Focus voltage	290.0	V
First anode voltage ,	1.0	kV
Control grid voltage for spot cut-off -V <sub>01</sub>	45.0	V
Nominal trace registration voltage V <sub>02</sub>	1.0	kV
Nominal beam blanking voltage V <sub>63</sub>	1.0	kV
Nominal geometry correction voltage . V <sub>s1</sub>	1.0	kV
Maximum y deflection factor D.	6.6	V/cm
Maximum x deflection factor D <sub>x</sub>	21.0	V/cm
*Typical line width (for type 24 phosphor	0.4	mm

<sup>\*</sup>Measured by means of a shrinking raster at the geometric centre of the face-plate.

# **DISPLAY CHARACTERISTICS**

#### Minimum Scanned Area

y (each gun)	-	•	٠	•	•			-		•							6	cm
y (overlap) .	•	٠	•	•	•	•	•			•	-	•	•				4	cm
The centre of	th	e 1	0 x	40	m	OV	erla	n r	ect	and	ا مار	النبه	l fa	11.4	ai e k	.:	. airala .	40

The centre of the 10 x 4 cm overlap rectangle will fall within a circle of 3 mm radius centred on the geometric centre of the faceplate.

# Beam Blanking

A potential of 50  $V/kV_{a1}$  (preferably negative) with respect to a1 applied to the blanking electrode g3, will completely cut off both beams. This electrode should not be used as a brightness control.

## Superimposition of Traces

The vertical traces may be superimposed along the vertical diameter by adjustment of the potential of the trace registration electrode g2, relative to a1, A range of adjustment of  $\pm$  10 V/kV $_{a1}$  may be required. Superimposition of the vertical traces at the extremes of x deflection may then be effected by adjustment of the relative cathode potentials. Provision should be made for a potential difference of up to 40 V/kV $_{a3}$  between the two cathodes for this purpose.

# Astigmatism Correction

Adjustment of the potential on a3 relative to the y deflection plate mean potential may be used for the purpose of astigmatism correction. A range of adjustment of  $\pm$  30 V/kV<sub>a3</sub> should be allowed for this purpose.

#### **Pattern Correction**

Barrel or pincushion distortion may be minimised by the application of the appropriate potential to s1 relative to the x plate mean potential. A range of adjustment from -30 to +30 V/kV<sub>a3</sub> should be allowed for this purpose. Astigmatism and pattern correction potentials are quoted for the condition where the x plate mean potential is equal to the y plate mean potential. If, in any application, a difference between x and y plate mean potentials is unavoidable, it is recommended that this difference should be kept to a minimum.

#### Pattern Distortion

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For each beam with pattern correction applied, the edges of a test raster will lie between two concentric rectangles of  $102 \times 51$  mm and  $100 \times 50$  mm. The angle between x and y axes (each beam) will be  $90^{\circ} \pm 1^{\circ}$ . The angle between y axes (beams superimposed) will be  $0^{\circ} \pm 1.5^{\circ}$ .

#### **Deflection Linearity**

The deflection factor for a deflection of less than 75 % of the useful scan will not differ from that for a deflection of 25 % by more than 2 %.

#### **Spot Position**

The focused and undeflected spots will fall within two 10 mm dia, circles whose centres lie on the geometric y — axis and  $\pm 10$  mm from the geometric centre of the faceplate.

#### Orientation

Looking at the screen with pins 9 and 10 of the base uppermost a positive potential applied to x1 will deflect the beam to the left and a positive potential applied to y1' or y1" will deflect the appropriate beam upwards.

#### MOUNTING

The tube may be mounted in any position but should not be supported by the base alone. It should preferably be held in a suitable rubber mask at the screen and by a clamp round the magnetic shield near the base. The socket should have sufficient freedom of movement to accommodate the maximum overall tube length and base orientation tolerances.

#### **BASE CONNECTIONS**

Base:	B12F	Side contact (CT8) : a4
Pin 1:	g1''	Pin 7: g1'
2:	k"	8 : k'
3:	h	9: g2 (trace registration)
4:	h	10: a1' and a1''
5 :	a2" (focus)	11: g3 (beam blanking)
6:	a2' (focus)	12 : IC

Side pin connections as viewed from base and reading clockwise from base pin 2:

x1 x2 a3" y2" y1" s1 (geometry) a3' y2' y1'

#### WEIGHT

The weight of the tube alone is 1.25 kg (2% lb).

# **MAGNETIC SHIELDING**

A suitable magnetic shield may be obtained from Magnetic Shields Ltd., Headcorn Road, Staplehurst, Tonbridge, Kent.

#### WARNING

Care should be taken not to expose the tube to stray magnetic fields either in use or during storage.

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## **OUTLINE**

